

INFORMATION DISCLOSURE CITATION				<i>Complete If Known</i>	
PTO-1449				<b>Application Number</b>	10/825,795
				<b>Filing Date</b>	April 13, 2004
				<b>First Named Inventor</b>	Jun Li
				Art Unit	3753
				Examiner Name	Teresa J. Walberg
Sheet 1 of 7				Attorney Docket Number	ARC-15173-1

## **U.S. PATENT DOCUMENTS**

Examiner Initials	Cite No.	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Class	Subclass	Filing Date if Appropriate
		Number - Kind Code <sup>1</sup>					
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Sheet	4	of	7	<u>Attorney Docket Number</u> ARC-15173-1

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		WO 03/054958A1	07-03-2003	Intel Corporation		'		
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